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PATENT APPLICATION



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Toshiro HAYAKAWA, et al.

Application No. 09/315,068

Group Art Unit: 2828

Confirmation No.: 5982

Examiner: Jeffrey N. Zahn

Filed: May 20, 1999

#15/Notice
of
Appeal
Marsha
4/4/02

For: SEMICONDUCTOR LASER AND METHOD OF MANUFACTURING THE SAME

NOTICE OF APPEAL

Commissioner for Patents
Washington, D.C. 20231

Sir:

Applicant hereby appeals to the Board of Patent Appeals and Interferences from the final Office Action dated November 1, 2002.

A check for the statutory fee of \$320.00 is attached. Please charge or credit any difference or overpayment to Deposit Account No. 19-4880. A duplicate copy of this sheet is enclosed.

04/02/2002 MGEBREM1 00000047 09315068

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Respectfully submitted,

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Date: April 1, 2002